

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Alessia Pavan et al.	§	Art Unit:	2894
Serial No.:	10/749,130	§		
Filed:	December 30, 2003	§	Examiner:	Amar Movva
For:	Non-Volatile Memory Cell Comprising Dielectric Layers Having a Low Dielectric Constant and Corresponding Manufacturing Process	§ § § § §	Conf No.:	3296
		§	Docket:	NUM.0104US 02-AG-317

Mail Stop **AF**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

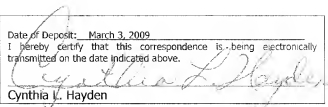
Sir:

In response to the office action mailed January 15, 2009, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made to the claims.

Date of Deposit: March 3, 2009

I hereby certify that this correspondence is being electronically transmitted on the date indicated above.


Cynthia L. Hayden